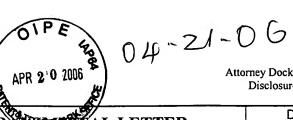
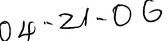
Express Mail No. EV853146857US







Attorney Docket No. 108298718US Disclosure No. 03-0120.00/US

AMENDMENT TRANSPORTAL LETTER						Docket No. 108298718US	
Applicatio 10/733,523-Co		Filing Date December 10, 2003		Examiner D. P. Turoc	y	Art Unit 1762	
Applicant(s): Beaman et al.							
Invention: METHODS AND SYSTEMS FOR CONTROLLING TEMPERATURE DURING MICROFEATURE WORKPIECE PROCESSING, E.G., CVD DEPOSITION							
TO THE COMMISSIONER FOR PATENTS							
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.							
CLAIMS AS AMENDED							
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate			
Total Claims	27	- 41 =		X			
Independent Claims	4	- 6 =		x	5		
Multiple Dependent Claims (check if applicable)							
Other fee (please specify):							
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:						0.00	
x Large Entity Small Entity							
x No additional fee is required for this amendment.							
Please charge Deposit Account No in the amount of \$ A duplicate copy of this sheet is enclosed.							
A check in the amount of \$ to cover the filing fee is enclosed.							
Payment by credit card. Form PTO-2038 is attached.							
The Director is hereby authorized to charge and credit Deposit Account No50-0665 as described below.							
x Credit any overpayment.							
x Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.							
Dated: April 20, 2006							
Chen Liang Attorney/Agent Reg. No.: 51,945							
PERKINS COIE LLP							
P.O. Box 1247 Seattle, Washington 98111-1247 (206) 359-8000							
(200) 000							

Attorney Docket No. 108298718US Disclosure No. 03-0120.00/US

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

KEVIN L. BEAMAN ET AL.

EXAMINER: DAVID P. TUROCY

APPLICATION NO.:

10/733,523

ART UNIT:

1762

FILED:

DECEMBER 10, 2003

CONF. NO:

9060

FOR:

METHODS AND SYSTEMS FOR

CONTROLLING TEMPERATURE

DURING MICROFEATURE

WORKPIECE PROCESSING, E.G., CVD

DEPOSITION

Amendment Under 37 C.F.R. § 1.111

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The present communication responds to the Office Action dated January 20, 2006 in the above-identified application. Please amend the application as reflected in the following list of claims.